## **EAST Search History**

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
S1	0	((fluorocarbon near dielectric) near8 contaminant) and ("carbon dioxide" near4 (fluid or liquid)) and (solvent or alcohol)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/03 11:07
S2	2	(fluorocarbon near dielectric) and ("carbon dioxide" near4 (fluid or liquid)) and (solvent or alcohol)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/03 11:26
S3	2	(substrate or semiconductor or wafer) and (fluorocarbon near dielectric) and ("carbon dioxide" near4 (fluid or liquid)) and (solvent or alcohol)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/03 11:42
S4	409	(substrate or semiconductor or wafer) and fluorocarbon and ("carbon dioxide" near4 (fluid or liquid)) and (solvent or alcohol)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/03 11:42
S5	297	(substrate or semiconductor or wafer) and fluorocarbon and ("carbon dioxide" near4 (fluid or liquid)) and (solvent or alcohol) and supercritical	US-PGPUB; USPAT; USOCR; EPQ; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/03 11:43
\$6	30	(substrate or semiconductor or wafer) and fluorocarbon and ("carbon dioxide" near4 (fluid or liquid)) and (solvent or alcohol) and supercritical and water and hydrofluorocarbon	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/03 11:43
S7	21	(substrate or semiconductor or wafer) and fluorocarbon and ("carbon dioxide" near4 (fluid or liquid)) and (solvent or alcohol) and supercritical and water and hydrofluorocarbon and (butanol or methanol or ethanol or propanol)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/03 12:10

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## **EAST Search History**

S8	0	(substrate or semiconductor or wafer) and fluorocarbon and ("carbon dioxide" near4 (fluid or liquid)) and silane and "nitrated fluorocarbon"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/03 12:10
S9	0	(substrate or semiconductor or wafer) and fluorocarbon and ("carbon dioxide" near4 (fluid or liquid)) and silane and "NFC"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/03 12:11
S10	0	(substrate or semiconductor or wafer) and fluorocarbon and ("carbon dioxide" near4 (fluid or liquid)) and silane and (nitrat\$4 near4 hydrocarbon)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/03 12:11
S11	36	silane and (nitrat\$4 near4 hydrocarbon)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/03 12:11
S12	13	silane and (nitrat\$4 near4 hydrocarbon) and (via or trench)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/03 12:11
S13	15	silane and (nitrat\$4 near4 hydrocarbon) and (via or trench or hole)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/03 12:12
S14		silane and (nitrat\$4 near4 hydrocarbon) and (via or trench or hole) and ("carbon dioxide" near4 fluid)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/03 12:12
S15	0	silane and (nitrat\$4 near4 hydrocarbon) and (via or trench or hole) and ("carbon dioxide" near8 fluid)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/03 12:12

## **EAST Search History**

S16	15	silane and (nitrat\$4 near4 hydrocarbon) and (via or trench or hole)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/03 12:13
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